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<b>APPLICANTS</b> Naoki Kusunoki, Tokyo, JAPAN; Nobutoshi Aoki, Kanagawa-ken, JAPAN; Hirotaka Amakawa, Kanagawa-ken, JAPAN; <i>M.S.</i>				
<b>** CONTINUING DATA *****</b> <i>NONE</i> <i>M.S.</i>				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN P2000-85268 03/24/2000 <i>M.S.</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE</b> <b>GRANTED ** 05/26/2001</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Verified and Acknowledged <i>M. S.</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 23	<b>TOTAL CLAIMS</b> 20
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> Mr. Roger R. Wise PILLSBURY MADISON & SUTRO LLP Suite 1200 725 South Figueroa Street Los Angeles, CA 90017				
<b>TITLE</b> Method of simulation of production process of semiconductor device and simulator thereof				
<b>FILING FEE RECEIVED</b> 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	